

03560.002558

PATENT APPLICATION

2851/
#16
IDS
5/16/03
R Jones

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Oyuji SUDOH, et al.) Examiner: H. Nguyen
Appln. No.: 09/532,022) Group Art Unit: 2851
Filed: March 21, 2000)
For: EXPOSURE APPARATUS AND A) March 11, 2003
METHOD WHICH KEEP)
TEMPERATURE OF A)
DIAPHRAGM OF A PROJECTION)
OPTICAL SYSTEM)
SUBSTANTIALLY CONSTANT)

The Commissioner for Patents
Washington, D.C. 20231

RECEIVED
MAR 17 2003
TC 2800 MAIL ROOM

INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed on February 9, 2000, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the listed documents are also enclosed.

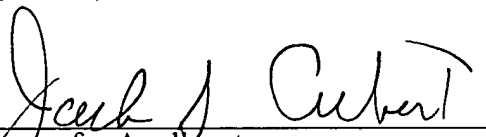
Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2). The Commissioner is authorized to charge Deposit Account No. 06-1205 should any other fees be deemed necessary in connection with this paper.

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Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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SEW/JSC/dc